

PATENT APPLICATION
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q85660

Heiji WATANABE, et al.

Appln. No.: 10/521,311

Group Art Unit: 2815

Confirmation No.: 1690

Examiner: WARREN, MATTHEW E

Filed: January 14, 2005

For: SEMICONDUCTOR DEVICE, AND MANUFACTURING METHOD AND
MANUFACTURING APPARATUS OF THE SAME

STATEMENT OF SUBSTANCE OF INTERVIEW

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Please review and enter the following remarks summarizing the interview conducted on
October 14, 2009:

REMARKS

An Examiner's Interview Summary Record (PTO-413) was issued and dated October 21,
2009.

During the interview, Applicants' representative indicated that the Applicants would put
the Application in condition for allowance by canceling the finally-rejected claims and amending
claim 9 as suggested by the Examiner. The supplemental, after-final Amendment to put the
Application in condition for allowance was filed October 13, 2009.

The Examiner agreed that the Application is in condition for allowance and would not go abandoned if the Notice of Allowance is not submitted before the 6 month statutory time period, since the Applicants filed a proper response and fees before October 15, 2009.

It is respectfully submitted that the instant STATEMENT OF SUBSTANCE OF INTERVIEW complies with the requirements of 37 C.F.R. §§1.2 and 1.133 and MPEP §713.04.

It is believed that no petition or fee is required. However, if the USPTO deems otherwise, Applicant hereby petitions for any extension of time which may be required to maintain the pendency of this case, and any required fee, except for the Issue Fee, for such extension is to be charged to Deposit Account No. 19-4880.

Respectfully submitted,


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WASHINGTON OFFICE

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CUSTOMER NUMBER

Date: November 3, 2009


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